



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wachtmann

Atty. Docket: 2550/185

Serial No.: 10/670,673

Art Unit: 2814

Filing Date: September 25, 2003

Date: July 11, 2005

Invention: METHOD OF FORMING A  
SURFACE MICROMACHINED  
MEMS DEVICE

Examiner: Pizarro Crespo, Marcos D

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Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450 Alexandria, VA 22313-1450 on July 11, 2005.

Steven G. Saunders

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AMENDMENT

Sir:

In response to the office action dated May 18, 2005, please amend the above-identified patent application as follows:

A listing of claims begins on page 2 of this paper.

Remarks begin on page 6 of this paper.